

PATENT Attorney Docket No.: <u>SLM-06100</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 2881
Gregory D. Miller et al	Examiner:
Serial No.: 10/047,550	TRANSMITTAL LETTER
Filed: January 15, 2002) 162 N. Wolfe Road) Sunnyvale, CA 94086 D ∞ D
For: METHOD FOR DOMAIN PATTERNING IN LOW	(408) 530-9700
COERCIVE FIELD	Customer No.: 28960
FERROELECTRICS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313	TECHNOLOGY
Sir:	Closure Statement and Form PTO-144%
Enclosed please find an Information Disc	closure Statement and Form PTO-1449
including copies of the references contained there	eon, for filing in the U.S. Patent and Trademark
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You will also find enclosed the associated Transmittals, Electronic Information Disclosure Statements, and United States Patent and Trademark Office Acknowledgment Receipts for the electronically filed Information Disclosure Statement (EFS ID # 43302); (EFS ID # 43303); (EFS ID # 43304); (EFS ID # 43305); (EFS ID # 43307); (EFS ID # 43308); (EFS ID # 43316); (EFS ID # 43312); (EFS ID # 43313); (EFS ID # 43314); (EFS ID # 43315); (EFS ID # 43316); (EFS ID # 43317); (EFS ID # 43318); and (EFS ID # 43319) filed on July 10, 2003.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. <u>08-1275</u>. An originally executed duplicate of this transmittal is enclosed for this purpose.

Respectfully submitted, HAVERSTOCK & OWENS LLP

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CERTIFICATE OF MAILING (37 CFR § 1.8(a))

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HAVERSTOCK & OWENS LLP.

Thomas B. Haverstock Reg. No.: 32,571

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Attorney Docket No.: <u>SLM-06100</u>

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In re Application of:	Group Art Unit: 2881		
Gregory D. Miller et al	Examiner:		0
Serial No.: 10/047,550) INFORMATION DISCLOSURE INFORMATION DISCLOSURE		7003
Filed: January 15, 2002	STATEMENT	ECI	18
For: METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS	162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700	T.	JUL 9
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The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

United States Patents or Published Patent Applications have been filed electronically (EFS ID #43302); (EFS ID #43303); (EFS ID #43304); (EFS ID #43305); (EFS ID #43307); (EFS ID #43308); (EFS ID #43309); (EFS ID #43311); (EFS ID #43312); (EFS ID #43313); (EFS ID #43314); (EFS ID #43315); (EFS ID #43316); (EFS ID #43317); (EFS ID #43318); and (EFS ID #43319). Applicants have become aware of the following printed publication which may be material to the examination of this application:

- U.S. Patent No. Des. 334,557;
- U.S. Patent No. Des. 334,742;
- U.S. Patent No. Des. 337,320;
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This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

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Attorneys for Applicants

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EXAMINER:

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(37 CFR § 1.98(b))

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary)

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Filing Date: January 15, 2002

Group Art Unit: 2881

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Attorney Docket No.: SLM-06100

Serial No.: 10/047,550

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary)

RE STATEMENT BY APPLICANT
Sheets If Necessary)

Applicants: Gregory D.Miller et al

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UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

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10/047550

EFS ID:

43302

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ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

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Gregory Miller

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File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100A-usidst.xml	20458
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100A-pkda.xml	1835
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	88370

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7e964883cf1a458c7a3987845d301d700e42dc51

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Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

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Date:

2002-01-15

First Named Applicant:

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Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Comments

10/047550

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD

Application Number: Confirmation Number:

Search string:

FERROELECTRICS

10/047550 5291 Gregory Miller First Named Applicant:

Attorney Docket Number: . (1525550 or 1548262 or 1814701 or 2415226 or 2783406 or 2920529 or 2991690 or 3256465 or 3388301 or 343871 or 3553346 or 3378394 or 3600798 or 3656837 or 3657610 or 3693239 or 3743507 or 3752563 or 37831485 or 3782916 or 3802769 or 3811186 or 3861784 or

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Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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Information Disclosure Statement

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Remarks

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UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43303

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WSVR1 I	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

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File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100B-usidst.xml	13945
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100B-pkda.xml	1835
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	81857

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0c86749deaa68419dbc5b27d8e1787dfd6a0d91b

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METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

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Gregory D. Miller

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Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Documents being submitted	Files	
us-ids	SLM06100B-usidst.xml	
	us-ids.dtd	
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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Application Number: 10/047550 Confirmation Number:

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First Named Applicant: Gregory Miller Attorney Docket Number:

Search string:

(4034399 or 4035068 or 4067129 or 4084437 or 4090219 or 4093346 or 4093921 or 4093922 or 4100579 or 4103273 or 4126380 or 4127322 or 41395502 or 4139257 or 4143943 or 4163570 or 4184700 or 4185581 or 4190855 or 4195915 or 4205428 or 4211918 or 4223950 or 4225913 or 4249796 or 4250217 or 4250393 or 4255767 or 4257016 or 4290672 or 4295145 or 4311999 or 4327411 or 4327966 or 4331972 or 4336982 or 4358680 or 4343535 or 4346985 or 4348079 or 4355463 or 4361384 or 4385824 or 43427497 or 4326780 or 4309868 or 4361384 or 4368824 or 43427497 or 4368824 4369524 or 4374397 or 4389096 or 4391490 or 4396246 or 4398798 or 4400740 or 4408884).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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Remarks

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Page 3 of 3

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Submission Type:

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Application Number:

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EFS ID:

43304

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ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
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File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100C-usidst.xml	14605
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100C-pkda.xml	1835
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	82517

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3a470933c6aa01ea773bc72a970e8020d6990303

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Information Disclosure Statement

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Confirmation Number: 5291

10/047550

First Named Applicant: Gregory Miller

Attorney Docket Number: (4414583 or 4417386 or 4418397 or 4420717 or 4422099 or 4426768 or Search string: 4430584 or 4435041 or 4440839 or 4443819 or 4443845 or 4447881 or

4454591 or 4456338 or 4460907 or 4462046 or 4467342 or 4468725 or 4483596 or 4484188 or 4487677 or 4492435 or 4503494 or 4511220 or 4538883 or 4545610 or 4556378 or 4558171 or 4561044 or 4566935 or 4567585 or 4571041 or 4571603 or 4577932 or 4577933 or 4588957 or 4590548 or 4594501 or 4596992 or 4615595 or 4623219 or 4636039 or 4638866 or 4641193 or 4645881 or 4646158 or 4649085 or 4649432 or 4652932 or 4655539).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	4414583	1983-11-08	Hooker, III]	358	300
	2	4417386	1983-11-29	Exner]	29	590
	3	4418397	1983-11-29	Brantingham et al.]	364	900
	4	4420717	1983-12-13	Wallace et al.]	318	696
	5	4422099	1983-12-20	Walfe]	358	293
	6	4426768	1984-01-24	Black et al.]	29	583
	7	4430584	1984-02-07	Someshwar et al.]	307	465
	В	4435041	1984-03-06	Torok et al.]	350	162.24
	9	4440839	1984-04-03	Mottler]	430	2
	10	4443819	1984-04-17	Funada et al.]	358	236
	11	4443845	1984-04-17	Hamilton et al.		364	200
	12	4447881	1984-05-08	Brantingham et al.]	364	488
	13	4454591	1984-06-12	Lou]	364	900
	14	4456338	1984-06-26	Gelbart]	350	358
	15	4460907	1984-07-17	Nelson]	346	153.1
	16	4462046	1984-07-24	Spight]	358	101

file://G:\!IDS-E-Filed\SLM06100\SLM06100C\SLM06100C-usidst.xml

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4467342 1984-08-21 357 Tower 30 18 4468725 1984-08-28 Venturini 363 160 19 4483596 1984-11-20 Marshall 350 385 20 4484188 1984-11-20 728 4487677 21 1984-12-11 Murphy 204 247 22 4492435 1985-01-08 Banton et al. 350 360 23 4503494 1985-03-05 Hamilton et al. 364 200 24 4511220 1985-04-16 350 403 Sprague et al. 25 4538883 1985-09-03 350 356 4545610 1985-10-08 29 589 4556378 1985-12-03 Nyfeler et al. 425 143 4558171 1985-12-10 174 28 Gantley et al. 52 FP 29 4561044 1985-12-24 Ogura et al. 362 84 30 4566935 1986-01-28 Hombeck 156 626 4567585 31 1986-01-28 369 97 353 4571041 1986-02-18 10 32 Gaudyn 4571603 1986-02-18 33 Hornbeck et al 346 160 34 4577932 1986-03-25 Gelbart 350 358 35 4577933 1986-03-25 Yip et al. 350 358 1986-05-13 37 4590548 1986-05-20 363 161 Maytum 38 4594501 1986-06-10 Culley et ai. 219 492 39 4596992 1986-06-24 346 76 PH 40 4615595 1986-10-07 Hornbeck 353 122 41 4623219 350 351 4636039 1987-01-13 356 42 Turner 350 43 4636866 1987-01-13 Hattori 358 236 44 4641193 1987-02-03 358 233 45 4645881 1987-02-24 LeToumelin et.al. 379 252 46 4646158 1987-02-24 358 Ohno et al. 236 4649085 1987-03-10 47 Landram 428 620 48 4649432 1987-03-10 Watanabe 358 241 49 4652932 1987-03-24 Miyajima et al. 358 236 50 4655539 1987-04-07 Cauffield et al 350 3.6

Remarks

Note: Remarks are not for responding to an office action.

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Signature

Examiner Name	Date

Page 3 of 3

UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43305

Server Response:

Confirmation Code	Message
ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 14:50:31 EDT

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us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100D-usidst.xml	13404
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100D-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	81286

Message Digest:

1b3ae7af949df88c823824d16502b35d5277e55c

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department of

Commerce,o=U.S. Government,c=US

TRANSMITTAL

Electronic Version v1.1 Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
	/tbh/	
Registered Number: 32571		Attorney

Comments

10/047550

Information Disclosure Statement

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD

Application Number: Confirmation Number: **FERROELECTRICS**

10/047550 5291 First Named Applicant: Gregory Miller

Attorney Docket Number:

Search string:

(4660938 or 4661828 or 4662746 or 4663670 or 4687326 or 4698602 or 4700276 or 4707064 or 4709995 or 4710732 or 4711526 or 4714326 or 4714326 or 471626 or 4714327 or 472593 or 472467 or 4726185 or 4714303 or 4744633 or 4747671 or 4755090 or 4762595 or 4763975 or 47 4804641 or 4807021 or 4807965 or 4809078 or 4811082 or 4811210 or 4814759 or 4817850 or 4824200 or 4827391 or 4829365 or 4836649 or 4856863 or 4856869 or 4859012 or 4859060 or 4866488 or 4882683 or 4893509 or 4896325).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

T-							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	4660938	1987-04-28	Kazan		350	355
	2	4661828	1987-04-28	Miller, Jr. et al.]	346	108
	3	4662746	1987-05-05	Hornbeck]	350	269
	4	4663670	1987-05-05	Ito et al.]	358	245
	5_	4687326	1987-08-18	Corby, Jr.]	356	5
	6	4698602	1987-10-06	Armitage]	332	7.51
	7	4700276	1987-10-13	Freyman et al.]	361	403
	8	4707064	1987-11-17	Dobrowolski et al.]	350	96.19
	9	4709995	1987-12-01	Kuribayashi et al.]	350	350
	10	4710732	1987-12-01	Hornbeck]	332	7.51
	11	4711526	1987-12-08	Hennings et al.		350	170
	12	4714326	1987-12-22	Usui et al.]	350	485
	13	4717066	1988-01-05	Goldenberg et al.]	228	179
	14	4719507	1988-01-12	Bos]	358	92
	15	4721629	1988-01-26	Sakai et al.]	427	35
	16	4722593	1988-02-02	Shimazaki]	350	336

file://G:\IDS-E-Filed\SLM06100\SLM06100D\SLM06100D-usidst.xml

7/10/2003

	17	4724467	1988-02-09	Yip et al.	355	71
	18	4728185	1988-03-01	Thomas	353	122
	19	4743091	1988-05-10	Gelbart	350	252
	20	4744633	1988-05-17	Sheiman	350	132
	21	4747671	1988-05-31	Takahashi et al.	350	336
	22	4751509	1988-06-14	Kubota et al.	340	784
	23	4761253	1988-08-02	Antes	264	1.3
	24	4763975	1988-08-16	Scifres et al.	350	96.15
	25	4765865	1988-08-23	Gealer et al.	156	647
	26	4772094	1988-09-20	Sheiman	350	133
	27	4797694	1989-01-10	Agostinelli et al.	346	160
	28	4797918	1989-01-10	Lee et al.	380	20
	29	4801194	1989-01-31	Agostinelli et al.	350	356
	30	4803560	1989-02-07	Matsunaga et al.	359	236
П	31	4804641	1989-02-14	Arit et al.	437	227
	32	4807021	1989-02-21	Okumura	357	75
	33	4807965	1989-02-28	Garakani	350	131
	34	4809078	1989-02-28	Yabe et al.	358	236
	35	4811082	1989-03-07	Jacobs et al.	357	80
	36	4811210	1989-03-07	McAulay	364	200
П	37	4814759	1989-03-21	Gombrich et al.	340	771
	38	4817850	1989-04-04	Wiener-Avnear et al.	228	119
	39	4824200	1989-04-25	Isono et al.	350	96.16
	40	4827391	1989-05-02	Sills	363	41
	41	4829365	1989-05-09	Eichenlaub	358	3
	42	4836649	1989-06-06	Ledebuhr et al.	350	331 R
	43	4856863	1989-08-15	Sampsell et al.	350	96.16
	44	4856869	1989-08-15	Sakata et al.	350	162.18
	45	4859012	1989-08-22	Cohn	350	96.24
	46	4859060	1989-08-22	Katagiri et al.	356	352
	47	4866488	1989-09-12	Frensley	357	4
	48	4882683	1989-11-21	Rupp et al.	364	521
	49	4893509	1990-01-16	Maciver et al.	73	517 AV
	50	4896325	1990-01-23	Coldren	372	20

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current

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Information Disclosure Statement

electronic filing contains part 4 out of a total of 16 electronic filings.

Signature

Examiner Name	Date

UNITED STATES PATENT AND TRADEMARK OFFICE **ACKNOWLEDGEMENT RECEIPT**

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43307

Server Response:

Confirmation Code	Message
MSVR1 I	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
19795	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 14:51:51 EDT

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us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100E-usidst.xml	13329
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100E-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
Total files si		81211

Message Digest:

633b8e7b0d7dbd6664e6e71916efa83aae0804cd

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Attorneys, ou=Patent and Trademark Office, ou=Department of

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Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Comments

10/047550

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD

Application Number: Confirmation Number:

FERROELECTRICS

10/047550 5291 First Named Applicant: Gregory Miller

Attorney Docket Number: Search string:

(4896948 or 4897708 or 4902083 or 4915463 or 4915479 or 4924413 or 4926241 or 4930043 or 4934773 or 4940309 or 4943815 or 4945773 or 4949148 or 4950890 or 4952925 or 4954789 or 4956619 or 4961633 or 4970575 or 4978202 or 4982184 or 4982265 or 4984824 or 4999308 or 5003300 or 5009473 or 5013141 or 5018256 or 5022750 or 5023905 or 5024494 or 5028939 or 5035473 or 5037173 or 5039628 or 5040052 or 5041395 or 5041851 or 5043917 or 5048077 or 5049901 or 5058992 or 5060058 or 5061049 or 5066614 or 5068205 or 5072239 or 5072418 or 5074947 or 5075940).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	4896948	1990-01-30	Dono et al.		350	355
	2	4897708	1990-01-30	Clements	١	357	65
	3	4902083	1990-02-20	Wells		350	6.6
	4	4915463	1990-04-10	Barbee, Jr.		350	1.1
	5	4915479	1990-04-10	Clarke		350	345
	6	4924413	1990-05-08	Suwannukul		364	521
	7	4926241	1990-05-15	Carey]	357	75
	8	4930043	1990-05-29	Wiegand		361	283
	9	4934773	1990-06-19	Becker		350	6.6
	10	4940309	1990-07-10	Baum		350	171
	11	4943815	1990-07-24	Aldrich et al.		346	108
	12	4945773	1990-08-07	Sickafus	Ī	73	862.59
	13	4949148	1990-08-14	Bartelink]	357	74
	14	4950890	1990-08-21	Gelbart		250	237 G
	15	4952925	1990-08-28	Haastert		340	784
	16	4954789	1990-09-04	Sampsell		330	4.3

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7/10/2003

Information Disclosure Statement

17	4956619	1990-09-11	Hornbeck	330	4.3
18	4961633	1990-10-09	Ibrahim et al.	350	392
19	4970575	1990-11-13	Soga et al.	357	72
20	4978202	1990-12-18	Yang	350	331 R
21	4982184	1991-01-01	Kirkwood	340	783
22	4982265	1991-01-01	Watanabe et al.	357	75
23	4984824	1991-01-15	Antes et al.	283	91
24	4999308	1991-03-12	Nishiura et al.	437	4
25	5003300	1991-03-26	Wells	340	705
26	5009473	1991-04-23	Hunter et al.	350	6.6
27	5013141	1991-05-07	Sakata	350	348
28	5018256	1991-05-28	Hornbeck	29	25.01
29	5022750	1991-06-11	Flasck	353	31
30	5023905	1991-06-11	Wells et al.	379	96
31	5024494	1991-06-18	Williams et al.	350	3.8
32	5028939	1991-07-02	Hombeck et al.	346	160
33	5035473	1991-07-30	Kuwayama el al.	350	3.7
34	5037173	1991-08-06	Sampsell et al.	385	17
35	5039628	1991-08-13	Carey	437	183
36	5040052	1991-08-13	McDavid	357	80
37	5041395	1991-08-20	Steffen	437	206
38	5041851	1991-08-20	Nelson	346	160
39	5043917	1991-08-27	Okamoto	364	518
40	5048077	1991-09-10	Wells et al.	379	96
41	5049901	1991-09-17	Gelbart	346	108
42	5058992	1991-10-22	Takahashi	359	567
43	5060058	1991-10-22	Goldenberg et al.	358	60
44	5061049	1991-10-29	Hornbeck	359	224
45	5066614	1991-11-19	Dunnaway et al.	437	209
46	5068205	1991-11-26	Baxter et al.	437	205
47	5072239	1991-12-10	Mitcham et al.	346	108
48	5072418	1991-12-10	Boutaud et al.	364	715.06
49	5074947	1991-12-24	Estes et al.	156	307.3
50	5075940	1991-12-31	Kuriyama et al.	29	25.03

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current

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Information Disclosure Statement

electronic filing contains part 5 out of a total of 16 electronic filings.

Signature

Examiner Name	Date

UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43308

Server Response:

Confirmation Code	Message
IISVRI	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 14:53:11 EDT

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File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100F-usidst.xml	13922
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100F-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	81804

Message Digest:

7c930b6a3ec576b5b2688949eb23a69f7af2800e

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

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Attorneys, ou=Patent and Trademark Office, ou=Department of

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Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

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Date:

2002-01-15

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Gregory D. Miller

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5291

Attorney Docket Number:

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Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Comments

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Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5079544 or 5081617 or 5083857 or 5085497 or 5089903 or 5093281 or 5096279 or 5099353 or 5101184 or 5101236 or 5103334 or 5105207 or 5105299 or 5105369 or 5107372 or 5112436 or 5113272 or 5113285 or 5115344 or 5119204 or 5121343 or 5126812 or 5126826 or 5126836 or 5128660 or 5129716 or 5132723 or 5132812 or 5136695 or 5137836 or 5142303 or 5142405 or 5142677 or 5144472 or 5147815 or 5148157 or 5148506 or 5149405 or 5150205 or 5151718 or 5151724 or 5151763 or 5153770 or 5155604 or 5155615 or 5155778 or 5155812 or 5157304 or 5159485 or 5161042).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5079544	1992-01-07	DeMond et al.		340	701
	2	5081617	1992-01-14	Gelbart		369	112
	3	5083857	1992-01-28	Hornbeck		359	291
	4	5085497	1992-02-04	Um et al.		359	848
	5	5089903	1992-02-18	Kuwayama et al.		359	15
	6	5093281	1992-03-03	Eshima		437	217
	7	5096279	1992-03-17	Hornbeck et al.		359	230
	8	5099353	1992-03-24	Hornbeck		359	291
	9	5101184	1992-03-31	Antes		235	454
	10	5101236	1992-03-31	Nelson et al.		355	229
	11	5103334	1992-04-07	Swanberg		359	197
	12	5105207	1992-04-14	Nelson		346	160
	13	5105299	1992-04-14	Anderson et al.		359	223
	14	5105369	1992-04-14	Nelson		364	525
	15	5107372	1992-04-21	Gelbart et al.		359	824
	16	5112436	1992-05-12	Bol		156	643

17	5113272	1992-05-12	Reamey
18	5113285	1992-05-12	Franklin et al.
19	5115344	1992-05-19	Jaskie
20	5119204	1992-06-02	Hashimoto et al.
21	5121343	1992-06-09	Faris
22	5126812	1992-06-30	Greiff
23	5126826	1992-06-30	Kauchi et al.
24	5126836	1992-06-30	Um
25	5128660	1992-07-07	DeMond et al.
26	5129716	1992-07-14	Holakovszky et al.
27	5132723	1992-07-21	Gelbart
28	5132812	1992-07-21	Takahashi et al.
29	5136695	1992-08-04	Goldshlag et al.
30	5137836	1992-08-11	Lam
31	5142303	1992-08-25	Nelson
32	5142405	1992-08-25	Hornbeck
33	5142677	1992-08-25	Ehlig et al.
34	5144472	1992-09-01	Sang, Jr. et al.
35	5147815	1992-09-15	Casto
36	5148157	1992-09-15	Florence
37	5148506	1992-09-15	McDonald
38	5149405	1992-09-22	Bruns et al.
39	5150205	1992-09-22	Um et al.
40	5151718	1992-09-29	Nelson
41	5151724	1992-09-29	Kikinis
42	5151763	1992-09-29	Marek et al.
43	5153770	1992-10-06	Harris
44	5155604	1992-10-13	Miekka et al.
45	5155615	1992-10-13	Tagawa
46	5155778	1992-10-13	Magel et al.
47	5155812	1992-10-13	Ehlig et al.
48	5157304	1992-10-20	Kane et al.
49	5159485	1992-10-27	Nelson
50	5161042	1992-11-03	Hamada

359	53
359	465
359	573
358	254
395	111
357	25
357	72
358	60
340	707
351	50
355	40
359	9
395	275
437	8
346	108
359	226
395	650
359	254
437	51
340	783
385	16
204	129.1
358	60
346	160
357	17
357	26
359	245
359	2
359	213
385	18
395	275
313	495
359	291
359	41

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current

UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43309

Server Response:

Confirmation Code	Message
ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 14:54:39 EDT

From:

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100G-usidst.xml	13328
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100G-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	81210

Message Digest:

d836c604f5b2958400871d35ffd4f61152fa8aa6

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys,ou=Patent and Trademark Office,ou=Department

of Commerce,o=U.S. Government,c=US

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Comments

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5162787 or 5164019 or 5165013 or 5168401 or 5168406 or 5170156 or 5170269 or 5170283 or 5172161 or 5172262 or 5177724 or 5178728 or 5179274 or 5179367 or 5181231 or 5182665 or 5185660 or 5188280 or 5189404 or 5189505 or 5191405 or 5192864 or 5192946 or 5198895 or 5202785 or 5206629 or 5208818 or 5208891 or 5210637 or 5212115 or 5212555 or 5212582 or 5214308 or 5214419 or 5214420 or 5216537 or 5216544 or 5219794 or 5220200 or 5221400 or 5221982 or 5224088 or 5226099 or 5230005 or 5231363 or 5231388 or 5231432 or 5233456 or 5233460 or 5233874).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5162787	1992-11-10	Thompson et al.		340	794
	2	5164019	1992-11-17	Sinton		136	249
	3	5165013	1992-11-17	Faris		395	104
	4	5168401	1992-12-01	Endriz		359	625
	5	5168406	1992-12-01	Nelson		359	855
	6	5170156	1992-12-08	DeMond et al.		340	794
	7	5170269	1992-12-08	Lin et al.		359	9
	8	5170283	1992-12-08	O'Brien et al.		359	291
	9	5172161	1992-12-15	Nelson		355	200
	10	5172262	1992-12-15	Hornbeck		359	223
	11	5177724	1993-01-05	Gelbart		369	44.16
	12	5178728	1993-01-12	Boysel et al.	+	156	656
	13	5179274	1993-01-12	Sampsell		250	208.2
	14	5179367	1993-01-12	Shimizu		340	700
	15	5181231	1993-01-19	Parikh et al.		377	26
	16	5182665	1993-01-26	O'Callaghan et al.		359	95

\		·				L
	17	5185660	1993-02-09	Um	358	60
	18	5188280	1993-02-23	Nakao et al.	228	123
	19	5189404	1993-02-23	Masimo et al.	340	720
	20	5189505	1993-02-23	Bartelink	257	419
	21	5191405	1993-03-02	Tomita et al.	257	777
	22	5192864	1993-03-09	McEwen et al.	250	234
	23	5192946	1993-03-09	Thompson et al.	340	794
	24	5198895	1993-03-30	Vick	358	103
	25	5202785	1993-04-13	Nelson	359	214
	26	5206629	1993-04-27	DeMond et al.	340	719
	27	5208818	1993-05-04	Gelbart et al.	372	30
	28	5208891	1993-05-04	Prysner	385	116
	29	5210637	1993-05-11	Puzey	359	263
	30	5212115	1993-05-18	Cho et al.	437	208
	31	5212555	1993-05-18	Stoltz	358	206
	32	5212582	1993-05-18	Nelson	359	224
	33	5214308	1993-05-25	Nishiquchi et al.	257	692
	34	5214419	1993-05-25	DeMond et al.	340	794
	35	5214420	1993-05-25	Thompson et al.	340	795
	36	5216537	1993-06-01	Hornbeck	359	291
	37	5216544	1993-06-01	Horikawa et al.	359	622
	38	5219794	1993-06-15	Satoh et al.	437	209
	39	5220200	1993-06-15	Blanton	257	778
	40	5221400	1993-06-22	Staller et al.	156	292
	41	5221982	1993-06-22	Faris	359	93
	42	5224088	1993-06-29	Atiya	369	97
	43	5226099	1993-07-06	Mignardi et al.	385	19
	44	5230005	1993-07-20	Rubino et al.	372	20
	45	5231363	1993-07-27	Sano et al.	332	109
	46	5231388	1993-07-27	Stoltz	340	783
	47	5231432	1993-07-27	Glenn	353	31
	48	5233456	1993-08-03	Nelson	359	214
	49	5233460	1993-08-03	Partlo et al.	359	247
	50	5233874	1993-08-10	Putty et al.	73	517 AV

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current

Information Disclosure Statement Page 3					
electronic filing contains part 7 out of a total of 16 electronic filing	gs.				
Signature					
Examiner Name	Date				

UNITED STATES PATENT AND TRADEMARK OFFICE **ACKNOWLEDGEMENT RECEIPT**

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43311

Server Response:

Confirmation Code	Message
ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 14:56:04 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100H-usidst.xml	14395
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsi	12026
package-data	SLM06100H-pkda.xml	1835
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	82307

Message Digest:

97e99d101bde218095a2fece789c10bbf8e82033

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys,ou=Patent and Trademark Office,ou=Department of

Commerce,o=U.S. Government,c=US

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock	/tbh/	
Registered Number: 32571		Attorney

Comments

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5237340 or 5237435 or 5239448 or 5239806 or 5240818 or 5245686 or 5247180 or 5247593 or 5249245 or 5251057 or 5251058 or 5254980 or 5255100 or 5256869 or 5258325 or 5260718 or 5260798 or 5262000 or 5272473 or 5278652 or 5278925 or 5280277 or 5281887 or 5281957 or 5285105 or 5285196 or 5285407 or 5287096 or 5287215 or 5289172 or 5291317 or 5291473 or 5293511 or 5296408 or 5296891 or 5296950 or 5298460 or 5299037 or 5299289 or 5300813 or 5301062 or 5303043 or 5303055 or 5307056 or 5307185 or 5310624 or 5311349 or 5311360 or 5312513 or 5313479).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5237340	1993-08-17	Nelson		346	108
	2	5237435	1993-08-17	Kurematsu et al.		359	41
	3	5239448	1993-08-24	Perkins et al.		361	764
	4	5239806	1993-08-31	Maslakow		53	432
	5	5240818	1993-08-31	Mignardi et al.		430	321
	6	5245686	1993-09-14	Faris et al.		385	120
	7	5247180	1993-09-21	Mitcham et al.		250	492.1
	8	5247593	1993-09-21	Lin et al.		385	17
	9	5249245	1993-09-28	Lebby et al.		385	89
	10	5251057	1993-10-05	Guerin et al.		359	249
	11	5251058	1993-10-05	MacArthur		359	249
	12	5254980	1993-10-19	Hendrix et al.		345	84
	13	5255100	1993-10-19	Urbanus		358	231
	14	5256869	1993-10-26	Lin et al.		250	201.9
	15	5258325	1993-11-02	Spitzer et al.		437	86
	16	5260718	1993-11-09	Rommelmann et al.		346	107 R

 	L	1	J
17	5260798	1993-11-09	Um et al.
18	5262000	1993-11-16	Welbourn et al.
19	5272473	1993-12-21	Thompson et al.
20	5278652	1994-01-11	Urbanus et al.
21	5278925	1994-01-11	Boysel et al.
22	5280277	1994-01-18	Hornbeck
23	5281887	1994-01-25	Engle
24	5281957	1994-01-25	Schoolman
25	5285105	1994-02-08	Cain
26	5285196	1994-02-08	Gale, Jr.
27	5285407	1994-02-08	Gale et al.
28	5287096	1994-02-15	Thompson et al.
29	5287215	1994-02-15	Warde et al.
30	5289172	1994-02-22	Gale, Jr. et al.
31	5291317	1994-03-01	Newswanger
32	5291473	1994-03-01	Pauli
33	5293511	1994-03-08	Poradish et al.
34	5296408	1994-03-22	Wilbarg et al.
35	5296891	1994-03-22	Vogt et al.
36	5296950	1994-03-22	Lin et al.
37	5298460	1994-03-29	Nishiguchi et al.
38	5299037	1994-03-29	Sakata
39	5299289	1994-03-29	Omae et al.
40	5300813	1994-04-05	Joshi et al.
41	5301062	1994-04-05	Takahashi et al.
42	5303043	1994-04-12	Glenn
43	5303055	1994-04-12	Hendrix et al.
44	5307056	1994-04-26	Urbanus
45	5307185	1994-04-26	Jones et al.
46	5310624	1994-05-10	Ehrlich
47	5311349	1994-05-10	Anderson et al.
48	5311360	1994-05-10	Bloom et al.
49	5312513	1994-05-17	Florence et al.
50	5313479	1994-05-17	Florence

358 233 156 643 345 7 358 160 385 14 345 108 310 335 345 8 257 672 345 108 365 189.11 345 108 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 9 437 183 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 223 359 572 156	358	000
345 7 358 160 385 14 345 108 310 335 345 8 257 672 345 108 365 189.11 345 108 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572		233
358 160 385 14 345 108 310 335 345 8 257 672 345 108 365 189.11 345 108 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	156	643
385 14 345 108 310 335 345 8 257 672 345 108 365 189.11 345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	345	7
345 108 310 335 345 8 257 672 345 108 365 189.11 345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	358	160
310 335 345 8 257 672 345 108 365 189.11 345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	385	14
345 8 257 672 345 108 365 189.11 345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	345	108
257 672 345 108 365 189.11 345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	310	335
345 108 365 189.11 345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	345	8
365 189.11 345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	257	672
345 147 359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	345	108
359 293 345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	365	189.11
345 108 359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	345	147
359 15 369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	359	293
369 112 257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	345	108
257 434 437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	359	15
437 203 355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	369	112
355 67 359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 572	257	434
359 9 437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 223 359 572	437	203
437 183 359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 223 359 572	355	67
359 41 359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 223 359 572	359	9
359 95 257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 223 359 572	437	183
257 752 359 567 348 40 348 761 340 189 359 41 430 322 359 223 359 572	359	41
359 567 348 40 348 761 340 189 359 41 430 322 359 223 359 572	359	95
348 40 348 761 340 189 359 41 430 322 359 223 359 572	257	752
348 761 340 189 359 41 430 322 359 223 359 572	359	567
340 189 359 41 430 322 359 223 359 572	348	40
359 41 430 322 359 223 359 572	348	761
430 322 359 223 359 572	340	189
359 223 359 572	359	41
359 572	430	322
	359	223
156 643	359	572
	156	643
372 26	372	26

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current

Information Disclosure Stateme	ent		Page 3 of 3
electronic filing contains pa	art 8 out of a total of 16 electronic	c filings.	
E	kaminer Name	Date	

UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43312

Server Response:

Confirmation Code	Message
ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 14:57:26 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100I-usidst.xml	14610
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100I-pkda.xml	1865
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	82552

Message Digest:

8742467f6b2f379fd639151d4b3318431573fbd8

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department

of Commerce,o=U.S. Government,c=US

Electronic Version v1.1 Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity	
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney	

Comments

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5313648 or 5313835 or 5315418 or 5315423 or 5319214 or 5319789 or 5319792 or 5321416 or 5323002 or 5323051 or 5325116 or 5327286 or 5329289 or 5330301 or 5330878 or 5331454 or 5334991 or 5339116 or 5339177 or 5340772 or 5345521 or 5347321 or 5347433 or 5347378 or 5348619 or 5349687 or 5351052 or 5352926 or 5354416 or 5357369 or 5357803 or 5359349 or 5359451 or 5361131 or 5363220 or 5365283 or 5367585 or 5371543 or 5371618 or 5382961 or 5387924 or 5389182 or 5391881 or 5392140 or 5392151 or 5394303 or 5398071 or 5399898 or 5404365 or 5404485).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5313648	1994-05-17	Ehlig et al.		395	800
	2	5313835	1994-05-24	Dunn		73	505
	3	5315418	1994-05-24	Sprague et al.		359	41
	4	5315423	1994-05-24	Hong		359	124
	5	5319214	1994-06-07	Gregory et al.		250	504 R
	6	5319789	1994-06-07	Ehlig et al.		395	800
	7	5319792	1994-06-07	Ehlig et al.		395	800
	8	5321416	1994-06-14	Bassett et al.		345	8
	9	5323002	1994-06-21	Sampsell et al.		250	252.1
	10	5323051	1994-06-21	Adams et al.		257	417
	11	5325116	1994-06-28	Sampsell		346	108
	12	5327286	1994-07-05	Sampsell et al.		359	561
	13	5329289	1994-07-12	Sakamoto et al.		345	126
	14	5330301	1994-07-19	Brancher		414	417
	15	5330878	1994-07-19	Nelson		430	311
	16	5331454	1994-07-19	Hornbeck		359	224

	L		4 L	l	L ————
	17	5334991	1994-08-02	Wells et al.	345
	18	5339116	1994-08-16	Urbanus et al.	348
	19	5339177	1994-08-16	Jenkins et al.	359
	20	5340772	1994-08-23	Rosotker	437
]	21	5345521	1994-09-06	McDonald et al.	385
	22	5347321	1994-09-13	Gove	348
	23	5347433	1994-09-13	Sedlmayr	362
	24	5347378	1994-09-13	Handschy et al.	359
	25	5348619	1994-09-20	Bohannon et al.	156
	26	5349687	1994-09-20	Ehlig et al.	395
	27	5351052	1994-09-27	D'Hont et al.	342
Ī	28	5352926	1994-10-04	Andrews	257
	29	5354416	1994-10-11	Okudaira	156
	30	5357369	1994-10-18	Pilling et al.	359
	31	5357803	1994-10-25	Lane	73
	32	5359349	1994-10-25	Jambor et al.	345
	33	5359451	1994-10-25	Gelbart et al.	359
Ī	34	5361131	1994-11-01	Tekemori et al.	356
	35	5363220	1994-11-08	Kuwayama et al.	359
	36	5365283	1994-11-15	Doherty et al.	348
	37	5367585	1994-11-22	Ghezzo et al.	385
	38	5371543	1994-12-06	Anderson	348
	39	5371618	1994-12-06	Tai et al.	359
	40	5382961	1995-01-17	Gale, Jr.	345
	41	5387924	1995-02-07	Gale, Jr. et al.	345
	42	5389182	1995-02-14	Mignardi	156
	43	5391881	1995-02-21	Jeuch et al.	250
	44	5392140	1995-02-21	Ezra et al.	359
	45	5392151	1995-02-21	Nelson	359
	46	5394303	1995-02-28	Yamaji	361
	47	5398071	1995-03-14	Gove et al.	348
	48	5399898	1995-03-21	Rostoker	257
	49	5404365	1995-04-04	Hiiro	372
	50	5404485	1995-04-04	Ban	395

040			
359	35		
437	226		
385	19		
348	663		
362	32		
359	53		
156	664		
395	800		
342	42		
257	717		
156	643		
359	462		
73	517 B		
345	168		
359	285		
356	355		
359	3		
348	743		
385	23		
348	270		
359	53		
345	108		
345	108		
156	344		
250	370.09		
359	41		
359	223		
361	749		
348	558		
257	499		
372	27		
395	425		

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current

Information Disclosure Statement	Page 3 of 3
electronic filing contains part 9 out of a total of 16 electronic	filings.
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Examiner Name	Date

UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43313

Server Response:

Confirmation Code	Message			
Submission was successfully submitted - Even if Informational or W Messages appear below, please do not resubmit this application				
ICON1	5291			
19795	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.			

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 14:58:49 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100J-usidst.xml	13975
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100J-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	81857

Message Digest:

597d10af81f79991df6018a7e251de991b631ddf

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department

of Commerce,o=U.S. Government,c=US

Electronic Version v1.1 Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock	/tbh/	
Registered Number: 32571		Attorney

Documents being submitted	Files	
us-ids	SLM06100J-usidst.xml	
	us-ids.dtd	
	us-ids.xsl	

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5408123 or 5410315 or 5411769 or 5412186 or 5412501 or 5418584 or 5420655 or 5420722 or 5426072 or 5427975 or 5430524 or 5435876 or 5438477 or 5439731 or 5442411 or 5442414 or 5444566 or 5445559 or 5446479 or 5447600 or 5448314 or 5448546 or 5450088 or 5450219 or 5451103 or 5452024 or 5452138 or 5453747 or 5453778 or 5453803 or 5454160 or 5454906 or 5455445 or 5455455 or 5455602 or 5457493 or 5457566 or 5457567 or 5458716 or 5459492 or 5459528 or 5459592 or 5459610 or 5461197 or 5461410 or 5461411 or 5461547 or 5463347 or 5463497 or 5465175).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5408123	1995-04-18	Murai		257	531
	2	5410315	1995-04-25	Huber		342	42
	3	5411769	1995-05-02	Hornbeck		427	534
	4	5412186	1995-05-02	Gale		219	679
	5	5412501	1995-05-02	Fisli	!	359	286
	6	5418584	1995-05-23	Larson		353	122
	7	5420655	1995-05 - 30	Shimizu		353	33
	8	5420722	1995-05-30	Bielak		359	708
	9	5426072	1995-06-20	Finnila		437	208
	10	5427975	1995-06-27	Sparks et al.		437	79
	11	5430524	1995-07-04	Nelson		355	200
	12	5435876	1995-07-25	Alfaro et al.		156	247
	13	5438477	1995-08-01	Pasch		361	689
	14	5439731	1995-08-08	Li et al.		428	209
	15	5442411	1995-08-15	Urbanus et al.		348	771
	16	5442414	1995-08-15	Janssen et al.		353	98

	·	1	·	
	17	5444566	1995-08-22	Gale et al.
	18	5445559	1995-08-29	Gale et al.
	19	5446479	1995-08-29	Thompson et al.
	20	5447600	1995-09-05	Webb
	21	5448314	1995-09-05	Heimbuch et al.
	22	5448546	1995-09-05	Pauli
	23	5450088	1995-09-12	Meier et al.
	24	5450219	1995-09-12	Gold et al.
	25	5451103	1995-09-19	Hatanaka et al.
	26	5452024	1995-09-19	Sampsell
	27	5452138	1995-09-19	Mignardi et al.
	28	5453747	1995-09-26	D'Hont et al.
司	29	5453778	1995-09-26	Venkateswar et al.
	30	5453803	1995-09-26	Shapiro et al.
	31	5454160	1995-10-03	Nickel
	32	5454906	1995-10-03	Baker et al.
_	33	5455445	1995-10-03	Kurtz et al.
司	34	5455455	1995-10-03	Badehi
	35	5455602	1995-10-03	Tew
	36	5457493	1995-10-10	Leddy et al.
	37	5457566	1995-10-10	Sampsell et al.
	38	5457567	1995-10-10	Shinohara
	39	5458716	1995-10-17	Alfaro et al.
	40	5459492	1995-10-17	Venkateswar
	41	5459528	1995-10-17	Pettitt
	42	5459592	1995-10-17	Shibatani et al.
	43	5459610	1995-10-17	Bloom et al.
	44	5461197	1995-10-24	Hiruta et al.
	45	5461410	1995-10-24	Venkateswar et al.
T	46	5461411	1995-10-24	Florence et al.
	47	5461547	1995-10-24	Ciupke et al.
Ī	48	5463347	1995-10-31	Jones et al.
	49	5463497	1995-10-31	Muraki et al.
	50	5465175	1995-11-07	Woodgate et al.

<u> </u>		
359	291	
451	388	
345	139	
216	2	
348	743	
369	112	
342	51	
359	40	
353	31	
348	755	
359	855	
342	42	
347	239	
353	119	
29	840	
216	66	
257	419	
257	690	
347	239	
348	164	
359	292	
359	305	
156	245	
347	253	
348	568	
359	40	
359	572	
174	52.4	
347	240	
347	240	
362	31	
330	253	
359	618	
359	463	

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current

Date

Examiner Name

UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43314

Server Response:

Confirmation Code	Message
III SVKI I	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 15:00:09 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100K-usidst.xml	13388
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100K-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
Total files size		81270

Message Digest:

aa88bf1f564971aaa3a925509328d914357c2981

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department of

Commerce,o=U.S. Government,c=US

Electronic Version v1.1 Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Comments

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5467106 or 5467138 or 5467146 or 5469302 or 5471341 or 5473512 or 5475236 or 5480839 or 5481118 or 5481133 or 5482564 or 5482818 or 5483307 or 5485172 or 5485304 or 5485354 or 5486698 or 5486841 or 5486946 or 5488431 or 5489952 or 5490009 or 5491510 or 5491612 or 5491715 or 5493177 or 5493439 or 5497172 or 5497197 or 5497262 or 5499060 or 5499062 or 5500761 or 5502481 or 5504504 or 5504514 or 5504575 or 5504614 or 5506171 or 5506597 or 5506720 or 5508558 or 5508561 or 5508565 or 5508750 or 5508841 or 5508841 or 5510758 or 5510824 or 5512374).pn.

US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5467106	1995-11-14	Salomon		345	87
	2	5467138	1995-11-14	Gove		348	452
	3	5467146	1995-11-14	Huang et al.		348	743
	4	5469302	1995-11-21	Lim		359	846
	5	5471341	1995-11-28	Warde et al.		359	293
	6	5473512	1995-12-05	Degani et al.		361	760
	7	5475236	1995-12-12	Yoshizaki		257	48
	8	5480839	1996-01-02	Ezawa et al.		437	209
	9	5481118	1996-01-02	Tew	3	250	551
	10	5481133	1996-01-02	Hsu		257	621
	11	5482564	1996-01-09	Douglas et al.		134	18
	12	5482818	1996-01-09	Nelson		430	394
	13	5483307	1996-01-09	Anderson		353	98
	14	5485172	1996-01-16	Sawachika et al.		345	8
	15	5485304	1996-01-16	Kaeriyama		359	291
	16	5485354	1996-01-16	Ciupke et al.		362	31

		L	4	L
	17	5486698	1996-01-23	Hanson et al.
	18	5486841	1996-01-23	Hara et al.
	19	5486946	1996-01-23	Jachimowicz et al.
	20	5488431	1996-01-30	Gove et al.
	21	5489952	1996-02-06	Gove et al.
	22	5490009	1996-02-06	Venkateswar et al.
	23	5491510	1996-02-13	Gove
	24	5491612	1996-02-13	Nicewarner, Jr.
	25	5491715	1996-02-13	FlaxI
	26	5493177	1996-02-20	Muller et al.
	27	5493439	1996-02-20	Engle
	28	5497172	1996-03-05	Doherty et al.
	29	5497197	1996-03-05	Gove et al.
	30	5497262	1996-03-05	Kaeriyama
	31	5499060	1996-03-12	Gove et al.
	32	5499062	1996-03-12	Urbanus
	33	5500761	1996-03-19	Goossen et al.
	34	5502481	1996-03-26	Dentinger et al.
	35	5504504	1996-04-02	Markandey et al.
	36	5504514	1996-04-02	Nelson
	37	5504575	1996-04-02	Stafford
	38	5504614	1996-04-02	Webb et al.
	39	5506171	1996-04-09	Leonard et al.
	40	5506597	1996-04-09	Thompson et al.
	41	5506720	1996-04-09	Yoon
	42	5508558	1996-04-16	Robinette, Jr. et al.
	43	5508561	1996-04-16	Tago et al.
	44	5508565	1996-04-16	Hatakeyama et al.
j	45	5508750	1996-04-16	Hewlett et al.
	46	5508840	1996-04-16	Vogel et al.
	47	5508841	1996-04-16	Lin et al.
	48	5510758	1996-04-23	Fujita et al.
	49	5510824	1996-04-23	Nelson
	50	5512374	1996-04-30	Wallace et al.

250 332 345 8 359 263 348 716 348 771 359 291 348 77 361 760 375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214 347 130
359 263 348 716 348 771 359 291 348 77 361 760 375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
348 716 348 771 359 291 348 77 361 760 375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
348 771 359 291 348 77 361 760 375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
359 291 348 77 361 760 375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
348 77 361 760 375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
361 760 375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
375 344 313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
313 578 359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
359 292 345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
345 85 348 388 359 223 348 651 348 771 359 290 348 51 345 214
348 388 359 223 348 651 348 771 359 290 348 51 345 214
359 223 348 651 348 771 359 290 348 51 345 214
348 651 348 771 359 290 348 51 345 214
348 771 359 290 348 51 345 214
359 290 348 51 345 214
348 51 345 214
345 214
347 130
100
356 330
359 223
437 187
345 85
359 224
257 700
257 737
257 777
348 558
359 291
359 318
333 247
247 220
347 239

Note: Remarks are not for responding to an office action.

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43315

Server Response:

Confirmation Code	Message	
IIISVRI I	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application	
ICON1	5291	
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.	

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 15:01:21 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100L-usidst.xml	13966
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100L-pkda.xml	1835
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	81878

Message Digest:

f2cf89b15b4b08fe9c9ff2d867641c369e333d93

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department

of Commerce,o=U.S. Government,c=US

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock	/tbh/	
Registered Number: 32571		Attorney

Documents being submitted	Files	
us-ids	SLM06100L-usidst.xml	
	us-ids.dtd	
	us-ids.xsl	

Electronic Version v18
Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5512748 or 5515076 or 5516125 or 5517340 or 5517347 or 5517357 or 5517359 or 5519251 or 5519450 or 5521748 or 5523619 or 5523628 or 5523803 or 5523878 or 5523881 or 5523920 or 5524155 or 5534107 or 5534883 or 5539422 or 5544306 or 5554304 or 5576878 or 5602671 or 5606181 or 5606447 or 5610438 or 5623361 or 5629566 or 5629801 or 5640216 or 5658698 or 5661592 or 5661593 or 5663817 or 5668611 or 5673139 or 5677783 or 5689361 or 5691836 or 5694740 or 5696560 or 5699740 or 5704700 or 5707160 or 5712649 or 5713652 or 5726480 or 5731802 or 5734224).pn.

US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5512748	1996-04-30	Hanson	!	250	332
	2	5515076	1996-05-07	Thompson et al.		345	139
	3	5516125	1996-05-14	McKenna		279	3
	4	5517340	1996-05-14	Doany et al.		359	41
	5	5517347	1996-05-14	Sampsell		359	224
	6	5517357	1996-05-14	Shibayama		359	547
	7	5517359	1996-05-14	Gelbart		359	623
	8	5519251	1996-05-21	Sato et al.		257	666
	9	5519450	1996-05-21	Urbanus et al.		348	600
	10	5521748	1996-05-28	Sarraf		359	321
	11	5523619	1996-06-04	McAllister et al.		257	686
	12	5523628	1996-06-04	Williams et al.		257	777
	13	5523803	1996-06-04	Urbanus et al.		348	771
	14	5523878	1996-06-04	Wallace et al.		359	290
	15	5523881	1996-06-04	Florence et al.		359	561
	16	5523920	1996-06-04	Machuga et al.		361	767

			L	
	17	5524155	1996-06-04	Weaver
	18	5534107	1996-07-09	Gray et al.
	19	5534883	1996-07-09	Koh
	20	5539422	1996-07-23	Heacock et al.
	21	5544306	1996-08-06	Deering et al.
	22	5554304	1996-09-10	Suzuki
	23	5576878	1996-11-19	Henck
	24	5602671	1997-02-11	Hornbeck
	25	5606181	1997-02-25	Sakuma et al.
	26	5606447	1997-02-25	Asada et al.
	27	5610438	1997-03-11	Wallace et al.
	28	5623361	1997-04-22	Engle
	29	5629566	1997-05-13	Doi et al.
	30	5629801	1997-05-13	Staker et al.
	31	5640216	1997-06-17	Hasegawa et al.
	32	5658698	1997-08-19	Yagi et al.
	33	5661592	1997-08-26	Bornstein et al.
	34	5661593	1997-08-26	Engle
	35	5663817	1997-09-02	Frapin et al.
	36	5668611	1997-09-16	Ernstoff et al.
	37	5673139	1997-09-30	Johnson
	38	5677783	1997-10-14	Bloom et al.
	39	5689361	1997-11-18	Damen et al.
	40	5691836	1997-11-25	Clark
	41	5694740	1997-12-09	Martin et al.
	42	5696560	1997-12-09	Songer
	43	5699740	1997-12-23	Gelbart
	44	5704700	1998-01-06	Kappel et al.
	45	5707160	1998-01-13	Bowen
	46	5712649	1998-01-27	Tosaki
	47	5713652	1998-02-03	Zavracky et al.
	48	5726480	1998-03-10	Pister
	49	5731802	1998-03-24	Aras et al.
$\neg \neg \vdash$	50	5734224	1998-03-31	Tagawa et al.

aa-	
385	24
156	643.1
345	3
345	8
395	164
216	2
359	224
359	224
257	88
359	199
257	682
359	291
257	789
359	572
349	58
430	11
359	291
359	292
349	5
348	771
359	291
359	224
359	284
359	247
53	431
348	436
101	477
353	31
400	472
345	8
353	122
257	415
345	148
313	493

Note: Remarks are not for responding to an office action.

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43316

Server Response:

Confirmation Code	Message			
ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application			
ICON1	5291			
11	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.			

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 15:02:44 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100M-usidst.xml	13961
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100M-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	81843

Message Digest:

a121245cace43b0427c89c66b9400975074dc600

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department of

Commerce,o=U.S. Government,c=US

Electronic Version v1.1 Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant: Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.

I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.

Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

Documents being submitted us-ids	Files SLM06100M-usidst.xml	
	us-ids.dtd us-ids.xsl	

Comments

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5742373 or 5744752 or 5745271 or 5757354 or 5757536 or 5764280 or 5768009 or 5773473 or 5793519 or 5798743 or 5798805 or 5801074 or 5802222 or 5808323 or 5808797 or 5815126 or 5825443 or 5835255 or 5835256 or 5837562 or 5841579 or 5844711 or 5847859 or 5862164 or 5868854 or 5886675 or 5892505 or 5895233 or 5898515 or 5903243 or 5903395 or 5910856 or 5912094 or 5912608 or 5914801 or 5915168 or 5919548 or 5920411 or 5920418 or 5923475 or 5926309 or 5926318 or 5942791 or 5949390 or 5949570 or 5953161 or 5955771 or 5978127 or 5982553 or 5986634).pn.

US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5742373	1998-04-21	Alvelda		349	204
	2	5744752	1998-04-28	McHerron et al.		174	52.4
	3	5745271	1998-04-28	Ford et al.		359	130
	4	5757354	1998-05-26	Kawamura		345	126
	5	5757536	1998-05-26	Ricco et al.		359	224
	6	5764280	1998-06-09	Bloom et al.		348	53
	7	5768009	1998-06-16	Little		359	293
	8	5773473	1998-06-23	Hall et al.		438	26
	9	5793519	1998-08-11	Furlani et al.		359	291
	10	5798743	1998-08-25	Bloom		345	90
	11	5798805	1998-08-25	Ooi et al.		349	10
	12	5801074	1998-09-01	Kim et al.		438	125
	13	5802222	1998-09-01	Rasch et al.		385	1
	14	5808323	1998-09-15	Spaeth et al.		257	88
	15	5808797	1998-09-15	Bloom et al.		359	572
	16	5815126	1998-09-29	Fan et al.		345	8

	<u></u>				
	17	5825443	1998-10-20	Kawasaki et al.	
	18	5835255	1998-11-10	Miles	
	19	5835256	1998-11-10	Huibers	
	20	5837562	1998-11-14	Cho	
	21	5841579	1998-11-24	Bloom et al.	
	22	5844711	1998-12-01	Long, Jr.	
	23	5847859	1998-12-08	Murata	
	24	5862164	1999-01-19	Hill	
	25	5868854	1999-02-09	Kojima et al.	
	26	5886675	1999-03-23	Aye et al.	
	27	5892505	1999-04-06	Tropper	
	28	5895233	1999-04-20	Higashi et al.	
	29	5898515	1999-04-27	Furlani et al.	
	30	5903243	1999-05-11	Jones	
	31	5903395	1999-05-11	Rallison et al.	
	32	5910856	1999-06-08	Ghosh et al.	
	33	5912094	1999-06-15	Aksyuk et al.	
	34	5912608	1999-06-15	Asada	
	35	5914801	1999-06-22	Dhuler et al.	
	36	5915168	1999-06-22	Salatino et al.	
	37	5919548	1999-07-06	Barron et al.	
	38	5920411	1999-07-06	Duck et al.	
Ī	39	5920418	1999-07-06	Shiono et al.	
	40	5923475	1999-07-13	Kurtz et al.	
	41	5926309	1999-07-20	Little	
	42	5926318	1999-07-20	Hebert	
	43	5942791	1999-08-24	Shorrocks et al.	
	44	5949390	1999-09-07	Nomura et al.	
	45	5949570	1999-09-07	Shiono et al.	
	46	5953161	1999-09-14	Troxell et al.	
	47	5955771	1999-09-21	Kurtz et al.	
	48	5978127	1999-11-02	Berg	
	49	5982553	1999-11-09	Bloom et al.	
ī	50	5986634	1999-11-16	Alioshin	

349	95
359	291
359	291
438	51
359	572
359	291
359	201
372	27
134	1.3
345	7
345	208
438	107
359	290
345	7
359	630
359	
	291
430	5
335	222
359	230
438	110
428	138
359	127
359	246
359	619
	293
359	618
257	522
345	32
359	291
359	618
257	419
359	279
359	627
345	126

Note: Remarks are not for responding to an office action.

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43317

Server Response:

Confirmation Code	Message
MOVE I	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 15:04:08 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100N-usidst.xml	14392
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100N-pkda.xml	1835
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	82304

Message Digest:

739cfd3b3b9c4f3dc428e3bcaa81e7664baa3b2f

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department

of Commerce,o=U.S. Government,c=US

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
1	/tbh/	
Registered Number: 32571		Attorney
	<u> </u>	

Documents being submitted	Files	
us-ids	SLM06100N-usidst.xml	
	us-ids.dtd	
	us-ids.xsl	

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5986796 or 5995303 or 5999319 or 6004912 or 6016222 or 6025859 or 6038057 or 6040748 or 6046840 or 6055090 or 6057520 or 6061166 or 6061489 or 6062461 or 6064404 or 6069392 or 6071652 or 6075632 or 6084626 or 6088102 or 6090717 or 6091521 or 6096576 or 6097352 or 6101036 or 6115168 or 6122299 or 6123985 or 6124145 or 6130770 or 6144481 or 6147789 or 6154259 or 6163026 or 6163402 or 6169624 or 6172796 or 6172797 or 6177980 or 6181458 or 6188519 or 6195196 or 6197610 or 6210988 or 6215579 or 6219015 or 6222954 or 6229650 or 6229683 or 6241143),pn.

US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5986796	1999-11-16	Miles		359	260
	2	5995303	1999-11-30	Honguh et al.		359	708
	3	5999319	1999-12-07	Castracane		359	573
	4	6004912	1999-12-21	Gudeman	(508	577
	5	6016222	2000-01-18	Setani et al.		359	571
	6	6025859	2000-02-15	lde et al.		347	135
	7	6038057	2000-03-14	Brazas, Jr. et al.		359	291
	8	6040748	2000-03-21	Gueissaz		335	78
	9	6046840	2000-04-04	Huibers		359	291
	10	6055090	2000-04-25	Miles		359	291
	11	6057520	2000-05-02	Goodwin-Johansson		200	181
	12	6061166	2000-05-09	Furlani et al.		359	254
	13	6061489	2000-05-09	Ezra		385	115
	14	6062461	2000-05-16	Sparks et al.		228	123.1
	15	6064404	2000-05-16	Aras et al.		345	507
	16	6069392	2000-05-30	Tai et al.		257	419

				_		<u> </u>
17	6071652	2000-06-06	Feldman et al.		430	5
18	6075632	2000-06-13	Braun]	359	124
19	6084626	2000-07-04	Ramanujan et al.]	347	239
20	6088102	2000-07-11	Manhart		356	354
21	6090717	2000-07-18	Powell et al.]	438	710
22	6091521	2000-07-18	Popovich		359	15
23	6096576	2000-08-01	Corbin et al.		438	108
24	6097352	2000-08-01	Zavracky et al.		345	7
25	6101036	2000-08-08	Bloom	1	359	567
26	6115168	2000-09-08	Zhao et al.	1	359	247
27	6122299	2000-09-19	DeMars et al.	Ī	372	20
28	6123985	2000-09-26	Robinson et al.		427	162
29	6124145	2000-09-26	Stemme et al.]	438	26
30	6130770	2000-10-10	Bloom		359	224
31	6144481	2000-11-07	Kowarz et al.		359	291
32	6147789	2000-11-14	Gelbart		359	231
33	6154259	2000-11-28	Hargis et al.		348	756
34	6163026	2000-12-19	Bawolek et al.		250	351
35	6163402	2000-12-19	Chou et al.		359	443
36	6169624	2001-01-02	Godil et al.	B1	359	237
37	6172796	2001-01-09	Kowarz et al.	B1	359	290
38	6172797	2001-01-09	Huibers	B1	359	291
39	6177980	2001-01-23	Johnson	B1	355	67
40	6181458	2001-01-30	Brazas, Jr. et al.	B1	359	290
41	6188519	2001-02-13	Johnson	B1	359	572
42	6195196	2001-02-27	Kimura et al.	B1	359	295
43	6197610	2001-03-06	Toda	B1	438	50
44	6210988	2001-04-03	Howe et al.	B1	438	50
45	6215579	2001-04-10	Bloom et al.	B1	359	298
46	6219015	2001-04-17	Bloom et al.	B1	345	87
47	6222954	2001-04-24	Riza	B1	385	18
48	6229650	2001-05-08	Reznichenko et al.	B1	359	566
49	6229683	2001-05-08	Goodwin-Johansoon	B1	361	233
50	6241143	2001-06-05	Kuroda	B1	228	110.1

Note: Remarks are not for responding to an office action.

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43318

Server Response:

Confirmation Code	Message
ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 15:05:32 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100O-usidst.xml	9451
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100O-pkda.xml	1805
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	77333

Message Digest:

8e10a525ffc2ed34dce4c8c88e1c42022e94a845

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys,ou=Patent and Trademark Office,ou=Department

of Commerce,o=U.S. Government,c=US

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock	/tbh/	
Registered Number: 32571		Attorney

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(6251842 or 6252697 or 6254792 or 6261494 or 6268952 or 6271145 or 6271808 or 6274469 or 6290859 or 6290864 or 6300148 or 6303986 or 6310018 or 6323984 or 6342960 or 6356577 or 6359333 or 6384959 or 6387723 or 6392309 or 6396789 or 6421179 or 6445502 or 6452260 or 6480634 or 6497490 or 6525863 or 6563974).pn.

US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6251842	2001-06-26	Gudeman	B1	508	577
	2	6252697	2001-06-26	Hawkins et al.	B1	359	290
	3	6254792	2001-07-03	Van Buskirk et al.	B1	216	13
	4	6261494	2001-07-17	Zavracky et al.	B1	264	104
	5	6268952	2001-07-31	Godil et al.	B1	359	291
	6	6271145	2001-08-07	Toda	B1	438	706
	7	6271808	2001-08-07	Corbin	B1	345	7
	- 8	6274469	2001-08-14	Yu	B1	438	592
	9	6290859	2001-09-18	Fleming et al.	B1	216	2
	10	6290864	2001-09-18	Patel et al.	B1	216	79
	11	6300148	2001-10-09	Birdsley et al.	B1	438	15
	12	6303986	2001-10-16	Shook	B1	257	680
	13	6310018	2001-10-30	Behr et al.	B1	510	175
	14	6323984	2001-11-27	Trisnadi	B1	359	245
	15	6342960	2002-01-29	McCullough	B1	359	124
	16	6356577	2002-03-12	Miller	B1	372	107
	17	6359333	2002-03-19	Wood et al.	B1	257	704
	18	6384959	2002-05-07	Furlani et al.	B1	359	291
	19	6387723	2002-05-14	Payne et al.	B1	438	48

					_	
20	6392309	2002-05-21	Wataya et al.	B1	257	796
21	6396789	2002-05-28	Guerra et al.	B1	369	112
22	6421179	2002-07-16	Gutin et al.	B1	359	572
23	6445502	2002-06-03	Islam et al.	B1	359	571
24	6452260	2003-09-17	Corbin et al.	B1	257	686
25	6480634	2002-11-12	Corrigan	B1	385	4
26	6497490	2002-12-24	Miller et al.	B1	359	614
27	6525863	2003-02-25	Riza	B1	359	290
28	6563974	2003-05-13	A. Riza	B2	385	18

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current electronic filing contains part 15 out of a total of 16 electronic filings.

Signature

Examiner Name	Date

Comments

Documents being submitted	Files	
us-ids	SLM06100O-usidst.xml	
	us-ids.dtd	
	us-ids.xsl	

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD **FERROELECTRICS**

Submission Type:

Information Disclosure Statement

Application Number:

10/047550

10/047550

EFS ID:

43319

Server Response:

Confirmation Code	Message
ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
ICON1	5291
1976	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Timestamp:

2003-07-10 15:06:57 EDT

From:

us

File Listing:

Doc. Name	File Name	Size (Bytes)
us-ids	SLM06100P-usidst.xml	4519
us-ids	us-ids.dtd	7763
us-ids	us-ids.xsl	12026
package-data	SLM06100P-pkda.xml	1835
package-data	package-data.dtd	27025
package-data	us-package-data.xsl	19263
	Total files size	72431

Message Digest:

cda46d04cd48419ae3d4d739ef74fba61b896b46

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered

Name:

Attorneys, ou=Patent and Trademark Office, ou=Department of

Commerce,o=U.S. Government,c=US

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Date:

2002-01-15

First Named Applicant:

Gregory D. Miller

Confirmation Number:

5291

Attorney Docket Number:

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I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.

Submitted by:	Elec. Sign.	Sign. Capacity		
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney		

Documents being submitted	Files	
us-ids	SLM06100P-usidst.xml	
	us-ids.dtd	
	us-ids.xsl	

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

METHOD FOR DOMAIN PATTERNING IN LOW COERCIVE FIELD FERROELECTRICS

Application Number:

10/047550

10/047550

Confirmation Number:

5291

First Named Applicant:

Gregory Miller

Attorney Docket Number:

Search string:

(5963788 or 6356689 or 5319668 or 20020015230 or 20020021485 or

20020079432 or 20020105725 or 20020112746 or 20020131230 or

20010019454).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
- (1	5963788	1999-10-05	Barron et al.		438	48
	2	6356689	2002-03-12	Greywall	B1	385	52
	3	5319668	1994-06-07	Luecke		372	107

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20020015230	2002-02-07	Pilossof et al.	A1	359	558
	2	20020021485	2002-02-21	Pilossof	A1	359	295
	3	20020079432	2002-06-27	Lee et al.	A1	250	216
	4	20020105725	2002-08-08	Sweatt et al.	A1	359	566
	5	20020112746	2002-08-22	DeYoung et al.	A1	134	36
	6	20020131230	2002-09-19	Potter	A1	361	277
	7	20010019454	2001-09-06	Tadic-Galeb et al.	A1	359	649

Remarks

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electronic filing contains part 16 out of a total of 16 electronic filings. Fee has been paid in previous electronic filing.

Signature

Examiner Name	Date